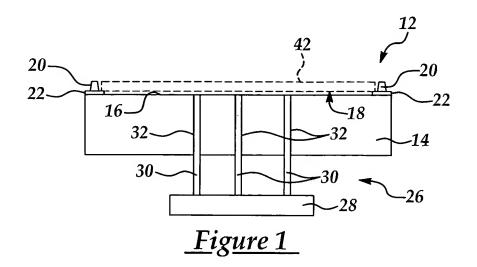
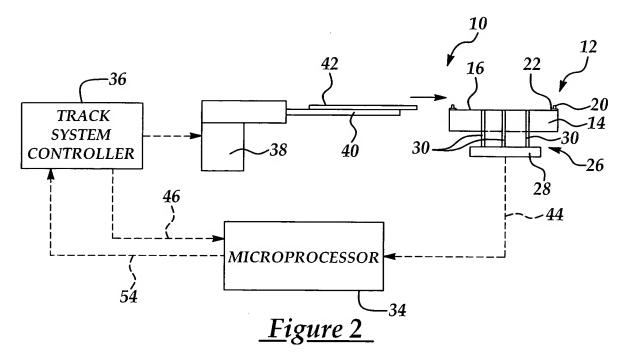
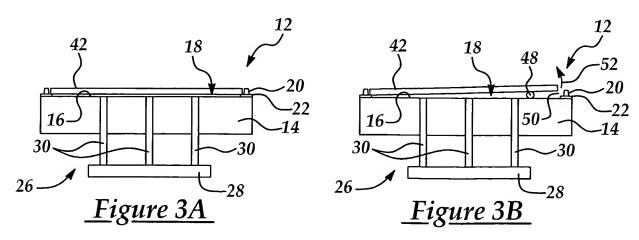
Serial No.: To Be Assigned Filed: Herewith

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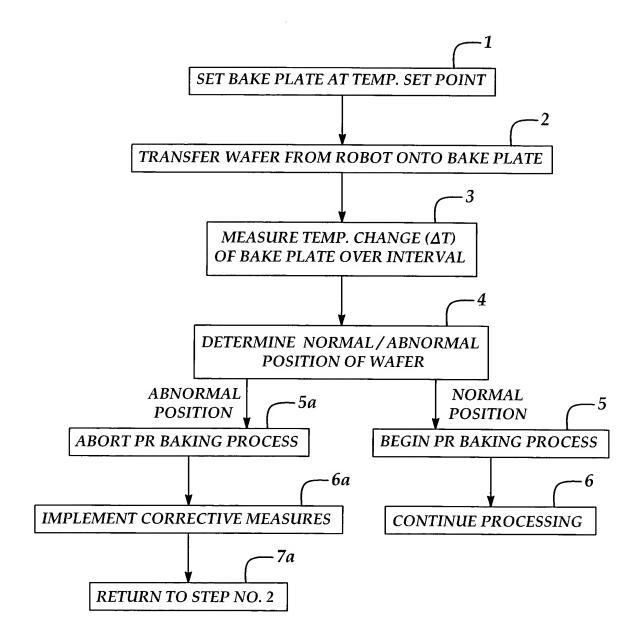






For: Temperature-Sensing Wafer Position Detection System and Method

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<u>Figure 4</u>

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